

ABLATIVE METHOD FOR FORMING RF CERAMIC BLOCK FILTERS

ABSTRACT OF THE DISCLOSURE

A method of forming metallization patterns on a block of dielectric material wherein the entire surface area of the dielectric block is encased with a conductive material and unwanted conductive metal is ablatively etched from a designated surface area of the dielectric block to form desired metallized circuit patterns.

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The invention also comprises a filter and a duplexer formed by the method of the present invention.